

**Notice of References Cited**Application/Control No.  
10/099,781Applicant(s)/Patent Under  
Reexamination  
KIM ET AL.Examiner  
Camie S ThompsonArt Unit  
1774

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-			
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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